

INFORMATION DISCLOSURE CITATION

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Applicant	Masahiko HASUNUMA et al.	
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U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS						
	Document Number	Publication Date	Country	Class	Sub Class	Translation Yes or No
DHA	11-176835	07/02/1999	Japan			No
	11-307633	11/05/1999	Japan			No
	2001-267323	09/28/2001	Japan			No
	2001-196372	07/19/2001	Japan			No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

b4-ll	Kurashima et al; "SEMICONDUCTOR DEVICE AND ITS MANUFACTURING METHOD"; U.S. Patent Application No. 10/640,004, filed August 14, 2003

Examiner	Kang, Donghee	Date Considered	11-29-04
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*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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